



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

October 5, 2026

IGI Report Number

Description

Shape and Cutting Style

Measurements

LG833669348

LABORATORY GROWN DIAMOND

EMERALD CUT

10.46 X 7.43 X 5.02 MM

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

Cut Grade

3.92 CARATS

D

VS 2

EXCELLENT

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence

Inscription(s)

EXCELLENT

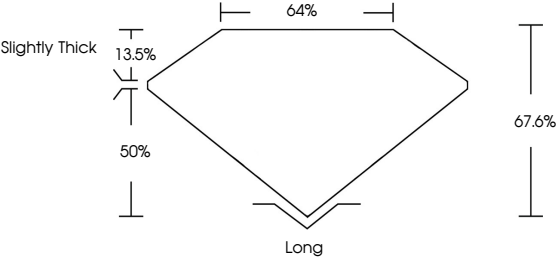
EXCELLENT

NONE

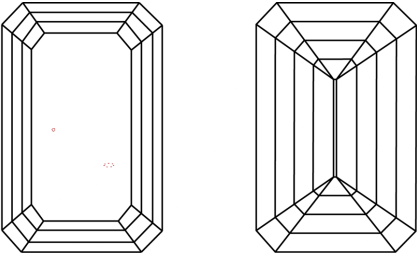
IGI LG833669348

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.

Green symbols indicate external characteristics.



Sample Image Used

COLOR

D

E

F

G

H

I

J

Faint

Very Light

Light

CLARITY

FL

IF

VVS¹⁻²

VS¹⁻²

SI¹⁻²

I¹⁻³

Flawless

Internally Flawless

Very Very Slightly Included

Very Slightly Included

Slightly Included

Included



INTERNATIONAL
GEMOLOGICAL
INSTITUTE



© IGI 2020, International Gemological Institute

FD - 10 20

LABORATORY GROWN DIAMOND REPORT



October 5, 2026

IGI Report Number

Description

Shape and Cutting Style

Measurements

LG833669348

LABORATORY GROWN DIAMOND

EMERALD CUT

10.46 X 7.43 X 5.02 MM

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

Cut Grade

3.92 CARATS

D

VS 2

EXCELLENT

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence

Inscription(s)

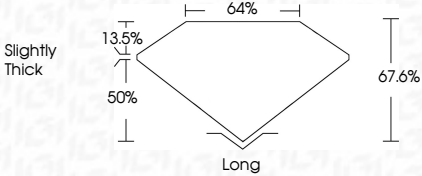
EXCELLENT

EXCELLENT

NONE

IGI LG833669348

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa





IGI



October 5, 2026

IGI Report No LG833669348

EMERALD CUT

10.46 X 7.43 X 5.02 MM

Carat Weight

Color Grade

Clarity Grade

Depth

Table

Girdle

Culet

Polish

Symmetry

Fluorescence

Inscription(s)

3.92 CARATS

D

VS 2

EXCELLENT

67.6%

64%

Slightly Thick

Long

EXCELLENT

EXCELLENT

NONE

IGI LG833669348

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa